IN THE UNITED STA

For:

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Examiner: Wilson, Lee

Art Unit: 2821

Docket No. P0877

Date: February 14, 2002

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CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, DC 20231 on February 12, 2003.

Signed: Sharon D. Tillery
Sharon D. Tillery

REQUEST TO RESCIND PREVIOUS NONPUBLICATION REQUEST

Commissioner for Patents Washington, DC 20231

Application No. 10/077,072

Filed: February 14, 2002

Plasma Processing Apparatus and Method for Confining an RF Plasma)
Under Very High Gas Flow and RF Power Density Conditions

Sir:

I hereby **rescind** the previous request that the above-identified application not be published under 35 U.S.C. § 122(b)(2)(B)(ii).

Respectfully submitted,

Lam Research Corporation

Michael S. Brandt

Reg. No. 39,119

4650 Cushing Parkway, CA-1 Fremont, CA 94536 Telephone (510) 572-1667 Customer No. 27787

Attorney Docket No. P0877